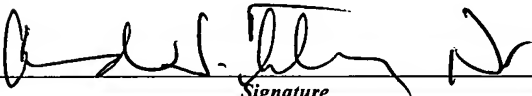


IFW

AMENDMENT TRANSMITTAL LETTER (Large Entity)					Docket No. OKI.616	
Applicant(s): Hiroyuki Fukunaga						
Application No. 10/761,223	Filing Date January 22, 2004	Examiner B. Kebede	Customer No. 20987	Group Art Unit 2823	Confirmation No. 2739	
Invention: METHOD OF MANUFACTURING NONVOLATILE SEMICONDUCTOR STORAGE DEVICE						
COMMISSIONER FOR PATENTS:						
Transmitted herewith is an amendment in the above-identified application. The fee has been calculated and is transmitted as shown below.						
CLAIMS AS AMENDED						
	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE	
TOTAL CLAIMS	12 -	20 =	0	x \$50.00	\$0.00	
INDEP. CLAIMS	3 -	3 =	0	x \$200.00	\$0.00	
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					\$0.00	
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0.00	
<input checked="" type="checkbox"/> No additional fee is required for amendment. <input type="checkbox"/> Please charge Deposit Account No. _____ in the amount of _____ <input type="checkbox"/> A check in the amount of _____ to cover the filing fee is enclosed. <input checked="" type="checkbox"/> The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account 50-0238 <input checked="" type="checkbox"/> Any additional filing fees required under 37 C.F.R. 1.16. <input checked="" type="checkbox"/> Any patent application processing fees under 37 CFR 1.17. <input type="checkbox"/> Payment by credit card. Form PTO-2038. WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038.						
 Signature			Dated: August 5, 2005			
ANDREW J. TELESZ, JR. REG. NO. 33,5891 VOLENTINE FRANCOS & WHITT, P.L.L.C. ONE FREEDOM SQUARE 11951 FREEDOM DRIVE, SUITE 1260 RESTON, VA 20190 TEL. NO. (571) 283-0720			<div style="border: 1px solid black; padding: 5px;"><p>I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)] on</p><p>_____ (Date)</p><p>_____ Signature of Person Mailing Correspondence</p><p>_____ Typed or Printed Name of Person Mailing Correspondence</p></div>			
CC:						



Serial No. 10/761,223
OKI.616
Amendment dated August 5, 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Hiroyuki Fukunaga

Group Art Unit: 2823

Serial No.: 10/761,223

Examiner: B. Kebede

Filed: January 22, 2004

Confirm: 2739

For: METHOD OF MANUFACTURING NONVOLATILE SEMICONDUCTOR
STORAGE DEVICE

AMENDMENT

U.S. Patent and Trademark Office
Customer Window, **Mail Stop Amendment**
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Date: August 5, 2005

Sir:

In response to the Office Action dated May 17, 2005, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

Amendments to the Specification begin on page 3 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 4 of this paper.

Serial No. 10/761,223
OKI.616
Amendment dated August 5, 2005

Remarks/Arguments begin on page 9 of this paper.